An Overview for the Sirius Vacuum System

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27th October 2021

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Outline

- Accelerators Layout
- Vacuum system overview
 - Fabrication
 - Installation
 - Vacuum performance
 - Vacuum related problems
 - IDs
- Final Remarks



CNPEM is a private institute, non-profit, supervised by the Brazilian Government



Accelerators layout





Storage Ring: layout for a typical sector



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Storage ring: multipole chambers



XXXIX CBRAVIC, Joinville, 2018

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Storage ring: dipole chambers



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Storage ring: pumping stations



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Main chambers and components: Special components





RF shielded bellows

Telescopic



Axial stroke: -9mm/+ 2mm Radial stroke: 0,02mm



Gear



Axial stroke: -5mm/+ 2mm Radial stroke: 0.5mm



12 units





Axial stroke: -9 mm/+ 2mm Radial stroke: 0.5 mm



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Main chambers and components: Special components



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NEG coating facility at CNPEM

License agreement signed with CERN in 2012



- Deposition of up to 3.2 m long chambers
- Magnetic field up to 600 Gauss
- Up to 6 straight chambers simultaneously
- Bake-out system integrated to the solenoids
- Automatic control of the deposition
- Individual control of each chamber







NEG coating production











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NEG coating production

About **1100 hours** of NEG coating

 Different crosssections, lengths, and materials









St. Steel – CF40 – vac. diagnostic cross







Installation – Storage Ring







Storage ring: Vacuum Performance





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Vacuum related problems



SR ion pump: pressure spikes when operated w/ voltage > 3kV



SR ion pump: short-circuit (1 units)



Photon beam exit port: hot spot



Booster inj. septum chamber: high voltage arc – vacuum leak



SR inj. septum chamber: high voltage arc – vacuum leak



Ver Scraper: coil spring popped up





IDs: Comissioning Undulators

Compact Linear Polarizing Undulator (CLPU)

Chambers' fabrication challenges:

- Tight Al extrusion and machining tolerances
- Small wall thickness: 0.5 ±0.1 mm
- Narrow gap = hard to NEG coat





Achieved Static Pressure <= 1.10⁻¹⁰ mbar



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IDs: Ongoing Work

• Delta long period (52.5 mm)

- Main challenges:
 - Mechanical tolerances
 - Chamber to magnet clearance = 0.25 mm
 - Assembling and NEG activation







Al extruded profile



- Delta short period (22 mm)
 - Main challenges:
 - Mechanical tolerances
 - NEG coating
 - Chambers' cooling > upstream dipole SR + image curr.
 - Chamber to magnet clearance = 0.025 mm
 - Assembling and NEG activation





Patent pending!







Sussccessfully developed

Final Remarks

- The vacuum system installation of the Sirius accelerators went well and was done in a short time
- The expected static pressures were achieved right after the vacuum installation, and the machine was delivered for starting the commissioning without delays
- Despite the few problems that we have faced until now, the vacuum has been performing well, and pressure has decreased as expect with beam conditioning. The design pressure was already achieved at accumulated beam dose of about 70 A·h
- R&Ds to fabricate the challenging chambers for the Delta undulators is ongoing and we hope to install the first prototypes in 2022





Thank you for your attention!

Aknowledgements:

- OFI Group
- MAT Group
- PRO Group
- LQU Group
- IMA Group
- CON Group
- DIG Group
- Engineering and Technology Division





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Backup slides







Special Heaters for Bake-out and NEG activation

Main characteristics of the special heaters:

- Developed along with a Brazilian company
- Thickness < 0.4 mm
- Voltage < 50V
- Max. operating temperature = 230 °C

Aluminum cov

Polyimide bonding film





Pyralux HT 8525R





Total of 1635 heaters are installed in the storate ring



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NEG films coated at LNLS









NEG coating R&D – Results



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NEG coating R&D – Results





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Chamber's cleaning procedure

Procedure:

- Tubes and components gross degreasing 1.
- Tubes etching LNLS procedure 2.
- 3. Copper components post-EDM processing???
- Fabrication process: machining, brazing, 4. welding, etc...
- Chambers degreasing 5.
- 6. Light deoxidizing:
 - ➢ 5% ammonium citrate

Developed cleaning procedure:

- 10% ammonium persulfate + 0,1% amonium 1. acetate (etching ~ 15 μ m)
- 5% H₂O₂ (helps to remove silver insoluble residuals) 2.
- 5% ammonium citrate (deoxide + passivation) 3.
 - -- Surface roughness < 0.4 μ m (Ra) --



XPS analysis – LNLS cleaned surface

Cleaning quality criteria (based on CERN):

Other contaminants should be analyzed MINISTRY OF CE, TECHNOLOGY

Silver



Dealing with unused Synchrotron Radiation



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Technical challenges





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Technical challenges







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NEG film

A NEG material is a metallic alloy that can pump most of the gases present in a vacuum system after thermal dissolution of its native oxide layer (activation process).



NEG, when in room temperature, do not pump methane and noble gases.

Adapted from: P. Chiggiato (CERN), ICTF-2005

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Storage ring: distinct cross-sections along the sector



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Storage Ring: Vacuum Performance



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